

ISSUE CLASSIFICATION	
Class	Subclass

FILED UNDER 35 U.S.C. 871

PATENT NUMBER

U.S. UTILITY Patent Application

O.I.P.E.

PATENT DATE

SCANNED

Q.A

APPLICATION NO. 09/463961	CONT/PRIOR D F	CLASS 423	SUBCLASS 2/0	ART UNIT 1754	EXAMINER VAN DYKE VAN DYKE
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APPLICANTS

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TITLE

METHOD AND APPARATUS FOR PROCESSING EXHAUST GAS OF SEMICONDUCTOR FABRICATION

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PTO-2040
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ISSUING CLASSIFICATION

[illegible]

<input type="checkbox"/> TERMINAL DISCLAIMER	DRAWINGS		CLAIMS ALLOWED		
	Sheets Drwg.	Figs. Drwg.	Print Fig.	Total Claims	Print Claim for O.G.
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<input type="checkbox"/> The term of this patent shall not extend beyond the expiration date of U.S. Patent. No. _____ _____ _____	<div style="text-align: center;">↙ Stanley S. Silverman Supervisory Patent Examiner Technology Center 1700 _____ (Primary Examiner)</div>		ISSUE FEE		
			Amount Due	Date Paid	
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